

Docket No.: OMY-013 (PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Kunie Ogata et al.

Application No.: 09/963,527

Group Art Unit: 1756

Filed: September 27, 2001

Examiner: J. Ruggles

For: RESIST PATTERN FORMING METHOD

(amended)

AMENDMENT (37 C.F.R. SECTION 1.111)

MS Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

In response to the Office Action dated May 5, 2004 (Paper No./Date 04272004), please amend the above-identified U.S. patent application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 4 of this paper.

Remarks/Arguments begin on page 9 of this paper.